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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4423**  
Tomohiro OKUMURA et al. : Docket No. 2001\_1089A  
Serial No. 09/918,823 : Group Art Unit 2821  
Filed August 1, 2001 : Examiner T. Phan

PLASMA PROCESSING METHOD  
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THE COMMISSIONER IS AUTHORIZED  
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Sir:

Attached hereto is a check in the amount of \$930.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time ..... \$930.00

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*The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.*

Respectfully submitted,

Tomohiro OKUMURA et al.

By

W. Douglas Hahm  
Registration No. 44,142  
Attorney for Applicants

WDH/lgs  
WENDEROTH, LIND & PONACK, L.L.P.  
2033 K St., N.W., Suite 800  
Washington, D.C. 20006-1021  
Telephone (202) 721-8200  
February 28, 2003

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